

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
)  
Takayuki ITO et al. )  
) Group Art Unit: TBA  
Application No.: Not Yet Assigned )  
) Examiner: TBA  
Filed: April 2, 2004 )  
)  
For: METHOD FOR )  
MANUFACTURING )  
SEMICONDUCTOR DEVICE, )  
INCLUDING MULTIPLE HEAT )  
TREATMENT )

**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

Sir:

**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)**

Pursuant to 37 C.F.R. §§1.56 and 1.97(b), applicants bring to the Examiner's attention the documents listed on attached Form PTO-1449. Copies of the listed documents are attached. Applicants respectfully request that the Examiner consider the documents listed on attached Form PTO-1449 and indicate that they were considered by making an appropriate notation on this form.

This Information Disclosure Statement is being filed with the above-referenced application.

The following are listed on the accompanying PTO-1449 and are in a non-English language. English-language abstracts are attached.

1. Japanese Patent Application (Laid-Open) Publication No. 2002-246329 - This document discloses the formation method of the ultra-shallow junction by 2 step annealing (lower temperature and longer time annealing / laser annealing).
2. Japanese Patent Application (Laid-Open) Publication No. 06-069149 - This document discloses the formation method of the ultra-shallow junction by 2 step annealing (lower temperature and longer time annealing / laser annealing).

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and applicants determine that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such documents. Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

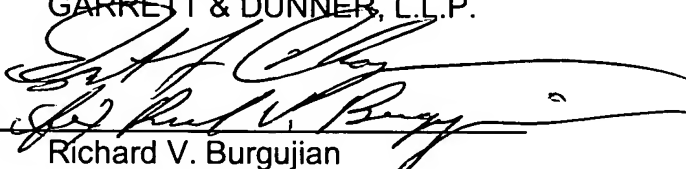
If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: April 2, 2004

By:

  
Richard V. Burgujian  
Reg. No. 31,744

Enclosures  
RVB/FPD/cma

ERNEST F. CHAPMAN  
Reg. No. 25,961

## INFORMATION DISCLOSURE CITATION

Atty. Docket No.	03180.0362	Application No.	TBA
Applicants	Takayuki ITO		
Filing Date	April 2, 2004	Group:	TBA

U.S. PATENT DOCUMENTS						
Examiner Initial*	Document Number	Issue Date (Publ. Date)	Name	Class	Sub Class	Filing Date If Appropriate
	2004-0018702 A1	(01/29/2004)	Ito et al.	438	530	

FOREIGN PATENT DOCUMENTS						
Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No	
2002-246329	08/30/2002	Japan			Abstract	
06-069149	03/11/1994	Japan			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	

Examiner	Date Considered
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce